Serial Number: 10/826,746 Filing Date: April 16, 2004

Title: HALL ELEMENT WITH SEGMENTED FIELD PLATE

IN THE CLAIMS

Please amend the claims as follows:

1. (Currently Amended) A Hall sensor comprising:

a Hall element supported by a substrate;

an insulating layer disposed over the Hall element; [[and]]

a segmented field plate positioned over the Hall element; and

feedback connection between sense outputs of the Hall element and the segmented field

<u>plate</u>.

2. (Cancelled)

3. (Currently Amended) The Hall sensor of claim 1 [[2]] and further comprising an amplifier coupled to the feedback connections between the sense outputs of the Hall element and the segmented field plate.

- 4. (Original) The Hall sensor of claim 3 wherein the feedback causes the Hall sensor to act as a latch.
- 5. (Original) The Hall sensor of claim 3 wherein the feedback causes a linear response of the Hall sensor.
- 6. (Original) The Hall sensor of claim 1 wherein the segmented field plate comprises four segments.
- 7. (Original) The Hall sensor of claim 6 wherein Hall element is substantially rectangular in shape and the segments are disposed in four separate quadrants defined by lines extending between opposite corners of the Hall element.
- 8. (Original) The Hall sensor of claim 7 wherein opposing diagonal segments are electrically connected.

Page 3 Dkt: 256.206US1

segments.

9. (Original) The Hall sensor of claim 8 wherein the Hall element comprises a positive bias corner, a negative bias corner, a positive sense corner and a negative sense corner, and wherein a differential feedback signal is provided to the pair of electrically connected, diagonally opposed

- 10. (Original) The Hall sensor of claim 1 wherein the segmented field plate comprises two segments.
- 11. (Original) The Hall sensor of claim 10 wherein Hall element is substantially square in shape and the segments each substantially cover two diagonally adjacent quadrants of the Hall element.
- 12. (Original) A Hall sensor comprising:
  - a Hall element supported by a substrate;
  - an insulating layer disposed over the Hall element;
  - a segmented field plate positioned over the Hall element; and means for applying dynamic bias control to the segmented field plate.
- 13. (Original) A Hall sensor comprising:
- a Hall element supported by a substrate, wherein the Hall element has a pair of sense outputs;
  - an insulating layer disposed over the Hall element;
  - a segmented field plate positioned over the Hall element; and
- an amplifier coupled to the sense outputs of the Hall element, the amplifier having outputs coupled to the segmented filed plate.
- 14. (Original) The Hall sensor of claim 13 wherein the amplifier comprises a fully differential amplifier.

Title: HALL ELEMENT WITH SEGMENTED FIELD PLATE

- (Original) The Hall sensor of claim 14 wherein the amplifier has a gain of between 15. approximately 200 and 500.
- 16. (Original) A Hall sensor comprising:
- a rectangular Hall element supported by a substrate, wherein the Hall element has a pair of sense outputs in opposing corners and a pair of bias outputs in opposing corners;
  - an insulating layer disposed over the Hall element;
- a four way segmented field plate positioned over separate quadrants of the Hall element defined by lines between opposing corners, wherein diagonally opposed filed plates are electrically coupled; and

an amplifier coupled to the sense outputs of the Hall element, the amplifier having outputs coupled to the segmented filed plate.

- (Original) The Hall sensor of claim 16 wherein the Hall element comprises a positive 17. bias corner, a negative bias corner, a positive sense corner and a negative sense corner, and wherein a differential feedback signal from the amplifier is presented to the pair of electrically connected, diagonally opposed segments.
- 18. (Original) A Hall sensor comprising:
  - a Hall element supported by a substrate;
  - an insulating layer disposed over the Hall element;
- a segmented field plate positioned over the Hall element, wherein the segments are electrically isolated from each other; and

feedback connections between sense outputs of the Hall element and the segmented field plate.

(Original) The Hall sensor of claim 18 wherein the Hall element is formed with an N-19. doped layer of semiconductor supported by a P-doped substrate.

- 20. (Original) The Hall sensor of claim 19 wherein the insulating layer comprises silicon dioxide.
- 21. (Currently Amended) A method of forming a Hall sensor, the method comprising: forming a Hall element;

forming an insulating layer over the Hall element;

forming a segmented conductive plate over the insulating layer to significantly cover the Hall element; and

forming conductors <u>coupled between the segmented conductive plate and Hall element</u> to provide dynamic bias control for the Hall element.

providing feedback to selected segments from sense contacts of the Hall element.

- 22. (Original) A method comprising:
  segmenting a field plate over a Hall element;
  electrically isolating segments of the field plate from each other; and
- 23. (Original) The method of claim 22 wherein the feedback is positive.
- 24. (Original) The method of claim 23 and further comprising amplifying the feedback to cause latching of the Hall element.
- 25. (Original) The method of claim 23 and further comprising amplifying the feedback to enhance magnetic responsivity while maintaining linearity.
- 26. (Original) The method of claim 22 wherein the feedback is negative.
- 27. (Original) The method of claim 26 and further comprising controlling the feedback to enhance linearity.